

FIG. 1A

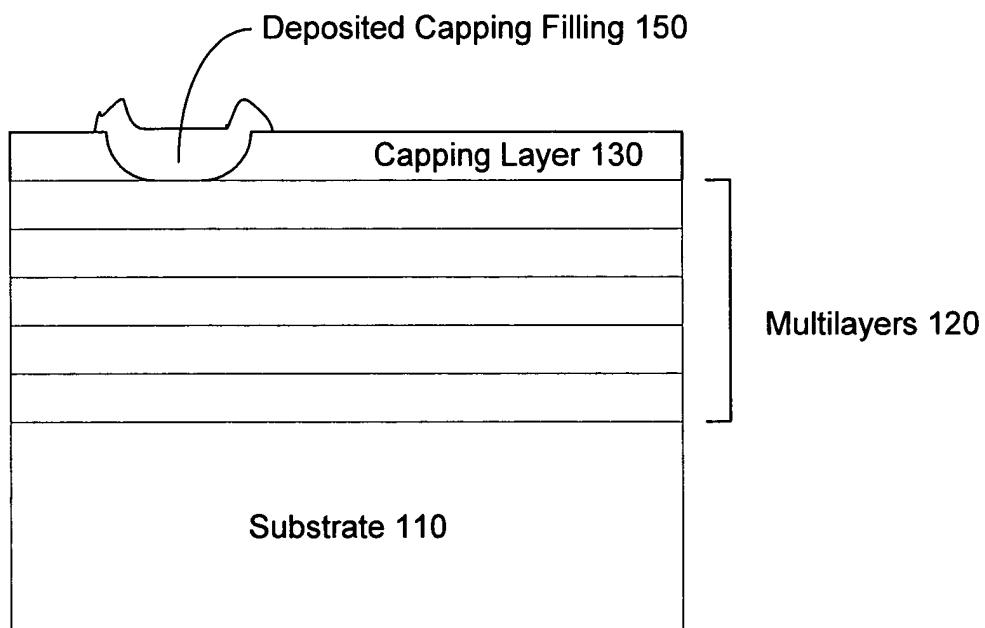


FIG. 1B

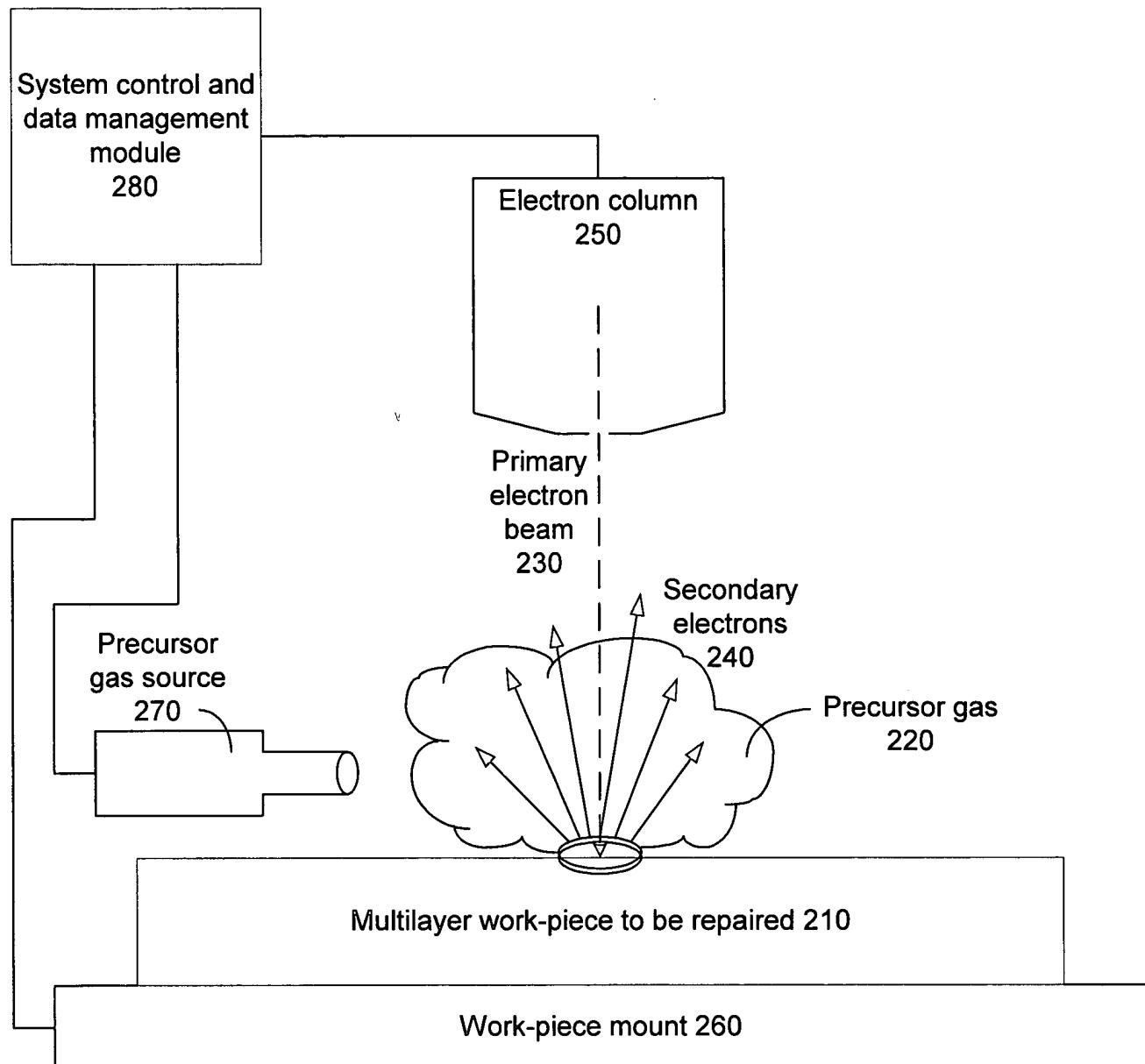


FIG. 2

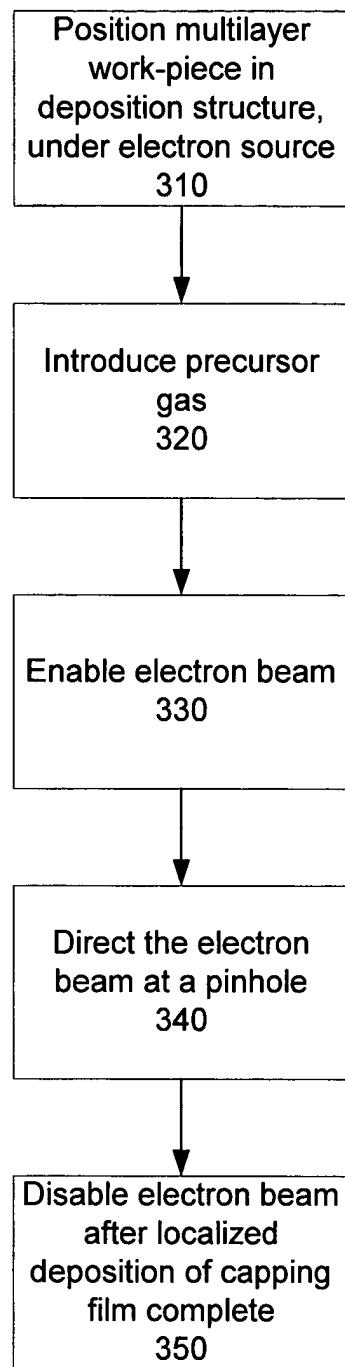


FIG. 3

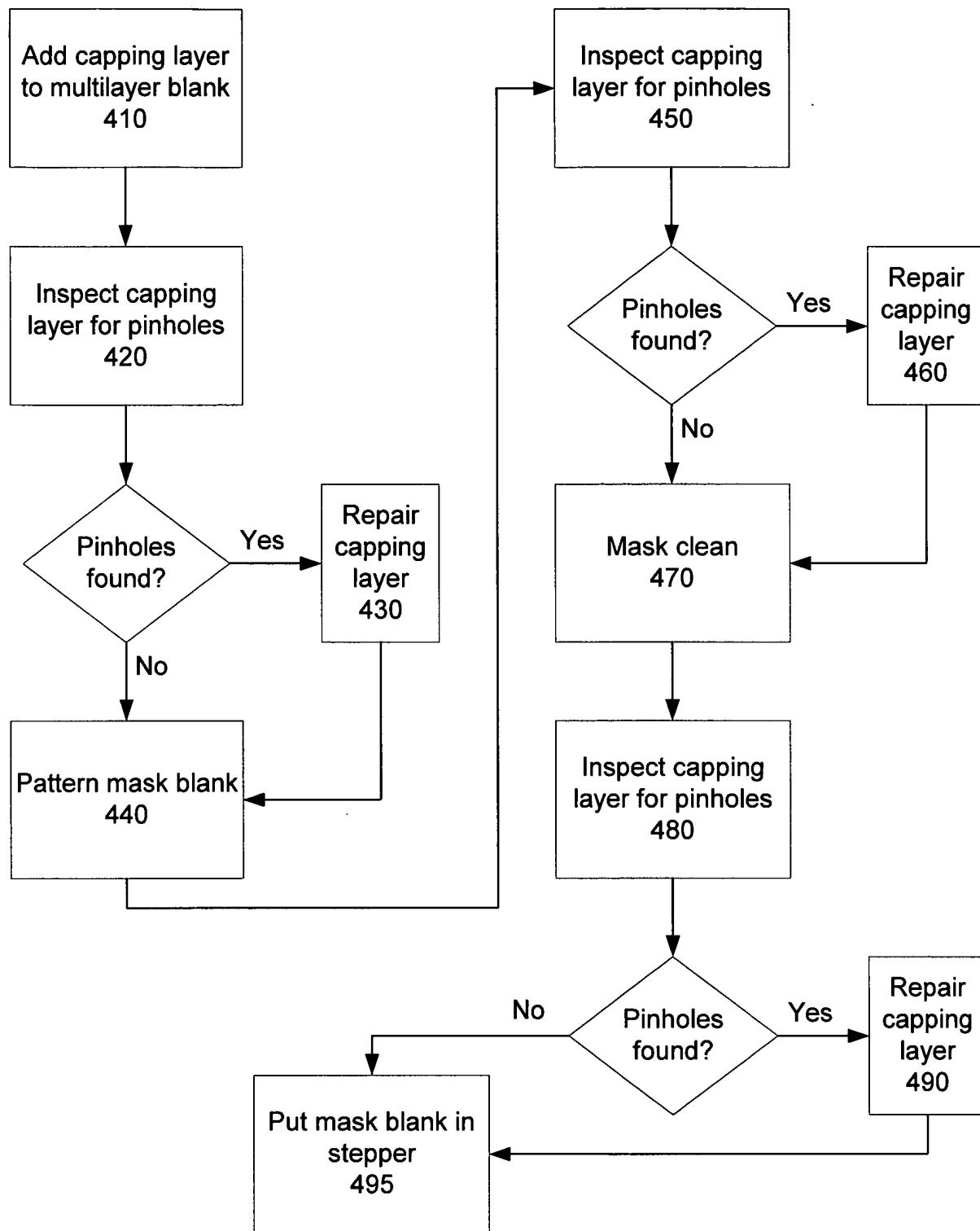


FIG. 4

Capping layer material 510	Precursor gas 520
Silicon	$\text{SiH}_4$ , $\text{Si}_2\text{H}_6$
Ruthenium	$\text{RuF}_6$ , $\text{Ru}(\text{CO})_5$ , $\text{Ru}_3(\text{CO})_{12}$
Carbon	$\text{CH}_4$

FIG. 5